

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q87267

Masahiko HATA

Appln. No.: 10/530,562

Confirmation No.: 8996

Group Art Unit: 1792

Filed: April 7, 2005

Examiner: Robert M. Kunemund

For: METHOD FOR PRODUCING THIN FILM CRYSTAL WAFER, SEMICONDUCTOR
DEVICE USING THE SAME AND METHOD FOR PRODUCING THE
SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.114(c)

MAIL STOP RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 8, 2010, please amend the above-identified application as follows on the accompanying pages. A Petition and payment for a three month extension of time are being filed herewith, making this Amendment due on or before July 8, 2010. A Request for Continued Examination (RCE) is being filed concurrently, also.

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